

**INFORMATION DISCLOSURE STATEMENT**

Applicant : Hayashi et al.  
App. No : 10/561,830  
Filed : December 22, 2005  
For : POSITIVE RESIST COMPOSITION  
AND METHOD OF FORMING  
RESIST PATTERN USING SAME  
Examiner : Ponder N. Thompson Rummel  
Art Unit : 1795

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF EFS WEB  
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I hereby certify that this correspondence, and  
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August 21, 2008

(Date)

Neil S. Bartfeld, Ph.D., Reg. No. 39,901

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 5 (five) references to be considered by the Examiner. Also enclosed are 4 (four) foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed after the mailing date of a final action or after the mailing date of a Notice of Allowance. This Statement is accompanied by the fee set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

**CERTIFICATION UNDER 37 C.F.R. § 1.97(e)(1)**

I hereby certify that each item of information contained in this Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 8/21/08

By: 

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